

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Takashi OZAKI, et al.**

Serial Number: **Not Yet Assigned**

(§371 of International Application PCT/JP2003/008097)

Filed: **December 23, 2004**

For: **SUBSTRATE TREATING APPARATUS AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 23, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report. Reference AA is cited in the International Search Report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 040509	Serial No. New Application
	Applicant(s): Takashi OZAKI, et al.	
	Filing Date: December 23, 2004	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	6,099,302	J.-h. Hong, et al.	08/08/00			
_____	AB						
_____	AC						
_____	AD						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	7-109574	04/25/95	Japan	Cited in the International Search Report
_____	AF	2000-106349	04/11/00	Japan	Cited in the International Search Report
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_____	AH	2000-91406	03/31/00	Japan	Cited in the International Search Report
_____	AI	11-186247	07/09/99	Japan	Cited in the International Search Report
_____	AJ	2002-217275	08/02/02	Japan	Cited in the International Search Report

OTHER DOCUMENTS

_____	AK			
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